

RECEIVED

FEB 26 2003

#1/A PB /3/03 PATENT

Customer No. 22,852 Attorney Docket No. 03327.2252

TECHNOLOGY CENTER 2000 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:)
Takatoshi YAMASHITA) Group Art Unit: 2881
Application No.: 09/773,664)) Examiner: M. El-Shammaa
Filed: February 2, 2001))
For:	ION SOURCE AND OPERATION METHOD THEREOF)))
Commissioner for Patents Washington, DC 20231		

Sir:

<u>AMENDMENT</u>

In response to the Office Action dated November 20, 2002, please reexamine and reconsider the application in view of the amendments and appended remarks.

IN THE SPECIFICATION:

Please replace the paragraph that begins on line 1 of page 4 and ends on line 5 of page 4 with the following paragraph:

FINNEGAN HENDERSON FARABOW GARRETT & DUNNER LLF

1300 I Street, NW Washington, DC 20005 202 408 4000

Fax 202.408.4400 www.finnegan.com As shown in FIG. 1, an ion beam 16 led out of the ion source contains a molecular ion (e.g., P_2^+ , As_2^+), which is an ion like a molecule, besides a monatomic ion (e.g., P^+ , As^+). The molecular ions include, for example, a diatomic ion composed of two atoms, and a triatomic ion composed of three atoms.